

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Tews, *et al.* Attorney Docket: 00P9031US
Filed: 11/16/2000 Examiner: Chen, Jack S.J.
Serial No.: 09/714,356 Art Unit: 2813
Title: Nitrogen Implantation Using A Shadow Effect To Control Gate Oxide Thickness

Commissioner for Patents
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Alexandria, VA 22313-1450

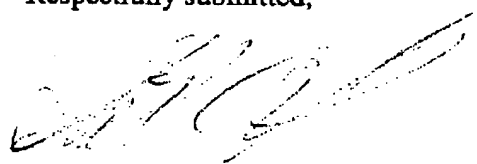
Associate Power of Attorney

I hereby appoint as associate attorneys of record all of the attorneys and agents at Customer Number 25962.

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Respectfully submitted,



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